



Attorney Docket
033082 M 115

P A T E N T

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:)	CONFIRMATION NO.: 3236
)	
Takayuki TOSHIMA, et al.)	
)	
U.S. Serial No.: 10/052,534)	Group Art Unit: 1746
)	
Filed: January 23, 2002)	Examiner: Michail Kornakov

For: SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE PROCESSING METHOD

SECOND INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

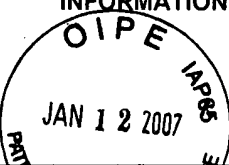
Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants enclose an Information Disclosure Citation Form (PTO-1449). This Information Disclosure Statement, together with a concurrently filed reply to an Office Action, constitutes a "submission" required as part of a Request for Continued Examination (RCE) as filed herewith.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,
SMITH, GAMBRELL & RUSSELL, LLP

By: 
Michael A. Makuch, Reg. No. 32,263
1850 M Street, N.W., Suite 800
Washington, D.C. 20036
Telephone: (202) 263-4300
Fax: (202) 263-4329

Date: January 12, 2007

FORM PTO-1449	ATTY. DOCKET 033082 M 115	SERIAL NO. 10/052,534
INFORMATION DISCLOSURE STATEMENT 	APPLICANTS: Takayuki TOSHIMA, et al.	
	FILING DATE January 23, 2002	GROUP ART UNIT 1746

U.S. PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE, IF APPROPRIAT E
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						

FOREIGN PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	<u>TRANS.</u>
	AH	2000-150439	05-30-2000	JP			Abstract
	AI	08-130202	05-21-1996	JP			Abstract
	AJ	61-098351	05-16-1986	JP			Abstract
	AK						

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

	AL	
	AM	
	AN	
	AO	
	AP	
EXAMINER:		DATE CONSIDERED:
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.		